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Applications Hexan+ = Group (iso/n-Hexane To Iso/n-Nonane) Heptan+ = Group (iso/n-Hexane) And Group (iso/n-Heptane To Iso/n-Nonane) N O Na+ = Group (is / -H Ex), Group (iso/n-Heptane), Group (iso/n-Octane), Group (is / N-N A E) C 1 To C 6 + +/- Oxygen C 1 To C 7 + C 1 To C 9 + Options 3th, 2024 Nanotwinned Metal MEMS Films With Unprecedented Strength ... Dimensional Stability Is Particularly Important In Capacitive-based Sensors And Guidance MEMS Devices, Where Dimensional Changes Caused by microstructural Evolution Or thermal expansion Must Be Significantly Less Than The Expected Changes Induced During Detection/ Operation Of The Device. Therefore, Thermal And Mechanical Stability Is Fig.2. 22th, 2024.

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